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L. Nelson
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant : Andreas Wiswesser, et al. Art Unit : Unknown
 Serial No. : 09/851,661 Examiner : Unknown
 Filed : May 8, 2001
 Title : METHOD AND APPARATUS FOR DETERMINING SUBSTRATE LAYER THICKNESS DURING CHEMICAL MECHANICAL POLISHING

Commissioner for Patents
 Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

Under 35 USC §120, this application relies on the earlier filing date of application serial number 09/237,472, filed on January 25, 1999. Except for reference AP, the references listed on the attached form PTO-1449 were submitted to and/or cited by the Patent Office in the prior application and, copies therefore, are not provided in this application.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits.

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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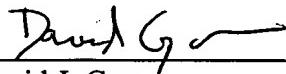
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Attorney's Docket No.: 05542-294002 / 2562C1/CMP

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Respectfully submitted,

Date: 9/9/01



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